

Notice of References Cited			Application/Control No.	Applicant(s)/Patent Under Reexamination	
			10/738,459 <i>3/11/07</i>	TOUR ET AL.	
Examiner <i>Edna Wong</i>			Art Unit	Page 1 of 1	
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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	C	US-7,014,737	03-2006	Harutyunyan et al.	204/158.2
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.